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Front Matter: Volume 10928

, "Front Matter: Volume 10928," Proc. SPIE 10928, High Contrast
Metastructures VIII, 1092801 (21 May 2019); doi: 10.1117/12.2531717

SPIE.

Event: SPIE OPTO, 2019, San Francisco, California, United States

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High Contrast Metastructures VIII

Connie J. Chang-Hasnain
Andrei Faraon
Weimin Zhou
Editors

4–7 February 2019
San Francisco, California, United States

Sponsored and Published by
SPIE

Volume 10928

Proceedings of SPIE 0277-786X, V. 10928

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

High Contrast Metastructures VIII, edited by Connie J. Chang-Hasnain, Andrei Faraon,
Weimin Zhou, Proc. of SPIE Vol. 10928, 1092801 · © 2019 SPIE
CCC code: 0277-786X/19/\$18 · doi: 10.1117/12.2531717

Proc. of SPIE Vol. 10928 1092801-1

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Author(s), "Title of Paper," in *High Contrast Metastructures VIII*, edited by Connie J. Chang-Hasnain, Andrei Faraon, Weimin Zhou, Proceedings of SPIE Vol. 10928 (SPIE, Bellingham, WA, 2019) Seven-digit Article CID Number.

ISSN: 0277-786X
ISSN: 1996-756X (electronic)

ISBN: 9781510624986
ISBN: 9781510624993 (electronic)

Published by

SPIE

P.O. Box 10, Bellingham, Washington 98227-0010 USA
Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445

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